| | Application No. | Applicant(s) |
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| | 10/747,637 | CHEN, WEI-CHEN |
| Notice of Allowability | Examiner | Art Unit |
| | Dameon E Levi | 2841 |
| The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI | (OR REMAINS) CLOSED in the or other appropriate communication. This application is sub- | nis application. If not included cation will be mailed in due course. THIS |
| 1. This communication is responsive to <u>Amendment 11/08/20</u> | <u>004</u> . | |
| 2. The allowed claim(s) is/are <u>3-21</u> . | | |
| 3. \boxtimes The drawings filed on <u>29 December 2003</u> are accepted by | the Examiner. | |
| 4. ☐ Acknowledgment is made of a claim for foreign priority una) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: | e been received. e been received in Application N | No |
| Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. | of this communication to file a IENT of this application. | reply complying with the requirements |
| 5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give | itted. Note the attached EXAM es reason(s) why the oath or de | INER'S AMENDMENT or NOTICE OF eclaration is deficient. |
| 6. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying Indicla such as the application number (see 37 CFR 1, each sheet. Replacement sheet(s) should be labeled as such in the | son's Patent Drawing Review (. s Amendment / Comment or in .84(c)) should be written on the c | the Office action of |
| 7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT | SIT OF BIOLOGICAL MATER FOR THE DEPOSIT OF BIOLO | IAL must be submitted. Note the DGICAL MATERIAL. |
| | · | |
| Attachment(s) 1. ☐ Notice of References Cited (PTO-892) | 5. Notice of Infor | mal Patent Application (PTO-152) |
| 2. Notice of Draftperson's Patent Drawing Review (PTO-948) | 6. 🔲 Interview Sum | mary (PTO-413), |
| 3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 | Paper No./Ma 98), 7. ☐ Examiner's An | nendment/Comment |
| Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit | 8. ⊠ Examiner's Sta | atement of Reasons for Allowance |
| of Biological Material | 9. Other | |
| | | |
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DETAILED ACTION

Allowable Subject Matter

Claims 3-21 are allowable.

The following is an examiner's statement of reasons for allowance: In response to remarks and claim amendments made in Applicant's Amendment submitted ... 11/08/2004, and, upon conclusion of a comprehensive search of the pertinent prior art, the Office indicates that the claims, as amended, are allowable.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Dameon E Levi whose telephone number is (571) 272-2105. The examiner can normally be reached on Mon.-Fri. (9:00 - 5:00).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kamand Cuneo can be reached on (571) 272-1957. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Dameon E Levi Examiner Art Unit 2841

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